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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Makoto INAI, et al.
Serial No.: 09/658,732
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New York, New York
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For: FIELD-EFFECT SEMICONDUCTOR DEVICE

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on May 10, 2001:

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Signature

May 10, 2001

Date of Signature

Respectfully submitted,


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